



03500.015262

PATENT APPLICATION —

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
: Examiner: M. Padgett
TAKESHI SHISHIDO ET AL.)
: Group Art Unit: 1762
Application No.: 09/822,191)
:
Filed: April 2, 2001)
:
For: EXHAUST PROCESSING METHOD,)
PLASMA PROCESSING METHOD :
AND PLASMA PROCESSING)
APPARATUS : April 26, 2006

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

SUBMISSION UNDER 37 C.F.R. §1.114

Sir:

(a) Introductory Comments

In response to the final Office Action dated December 29, 2005, kindly
amend the subject application as follows.